

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	Tsuyoshi MATSUDA; Tatsuhiko HIRANO; Junhui OH; Atsunori KAWAMURA; Kenji SAKAI
Application No.:	10/574115
Filed:	September 30, 2004
For:	POLISHING COMPOSITION AND POLISHING METHOD
Examiner:	Michael A. Marcheschi
Group Art Unit:	1793
Confirmation No.:	5670

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Docket No.: O11.21-13210-US01

RESPONSE TO RESTRICTION REQUIREMENT

This communication is in response to the Restriction Requirement dated **January 16, 2008**.

If an extension of time is required to make this response timely and no separate petition is enclosed, Applicants hereby petition for an extension of time sufficient to make the response timely. In the event that this response requires the payment of government fees and payment is not enclosed, please charge Deposit Account No. 22-0350.